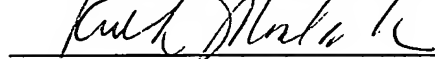


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 / Ruth Montalvo Date: 12/22/05

Customer No. 026418

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney's Docket No.: JG-SU-5224/500577.20073

U.S. Application No.:

International Application No.: PCT/JP2005/006268

International Filing Date: MARCH 31, 2005

31 MARCH 2005

Priority Date Claimed: APRIL 05, 2004

04 APRIL 2004

Title of Invention: **MANUFACTURING METHOD OF SEMICONDUCTOR WAFER AND SEMICONDUCTOR WAFER MANUFACTURED BY THIS METHOD**
Applicant(s) for (DO/EO/US): **Syoudji NOGAMI, Yukichi HORIOKA, and Shoichi YAMAUCHI**

Mail Stop PCT
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-450

INFORMATION DISCLOSURE STATEMENT

S I R:

Applicant herewith submits together with the simultaneously filed National Phase application of PCT/EP2003/013475, a copy of the International Search Report (PCT/ISA/210) dated May 4, 2004, citing some of the following references:

	Document Number	Date	Name and/or Country	English Translation and/or Equivalent
AA	6,495,294	12/17/2002	Yamauchi, et al.	
AL	2001-196573	07/19/2001	Japan	US 6,495,294
AM	2003-218037	07/31/2003	Japan	Abstract only

Accompanying this Information Disclosure Statement and form PTO-1449 are copies of the documents including English Abstract and US equivalent. Document AL is mentioned on page 2 of the substitute specification.


The USPTO waived the requirement under 37 C.F.R. §1.98(a)(2)(i) for submitting copies of US patents and US patent application publications in all U.S. applications filed after June 30, 2003. First pages of US documents only.

This submission is not an admission that the information disclosed in the documents is material to the patentability of the invention disclosed and/or claimed in the above-identified application.

Respectfully submitted,

JG:ram
12/22/05
Tel. (212) 521-5400

Enclosures:
Search Report (PCT/ISA/210);
PTO-1449
1 first page US Patents
2 foreign documents
2 English Abstracts


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LIST OF PRIOR ART CITED BY APPLICANT
(Filed on December 22, 2005)

Docket No. **JG-SU-5224/500577.20073**Applicant(s): **Syouji NOGAMI, Yukichi HORIOKA, and Shoichi YAMAUCHI**

Application No. (Int'l Appln No. PCT/JP2004/006268 31MAY05) Group:

Filed: Examiner:

U.S. PATENT DOCUMENTS

Exam. Init		Document Number	Date	Name	Class	Sub-Class	Filing Date Appropriate
	AA	6,495,294	12/17/2002	Yamauchi, et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	CLASS	Sub-Class	Translation YES	NO
	AL	2001-196573	07/19/2001	Japan			US 6,495,294	
	AM	2003-218037	07/31/2003	Japan			Abstract only	
	AN							
	AO							
	AP							
	AQ							
	AR							
	AS							
	AT							

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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